

Development of a kHz laser-plasma accelerator for ultrafast electron diffraction



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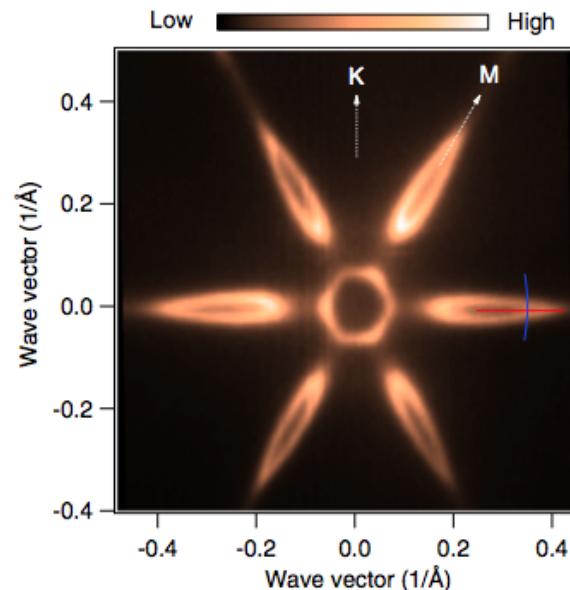
Motivations

Physics

- Ultrafast dynamics in condensed matter
- Dynamics of phase transitions
- Coupling of electronic, spin, lattice degrees of freedom

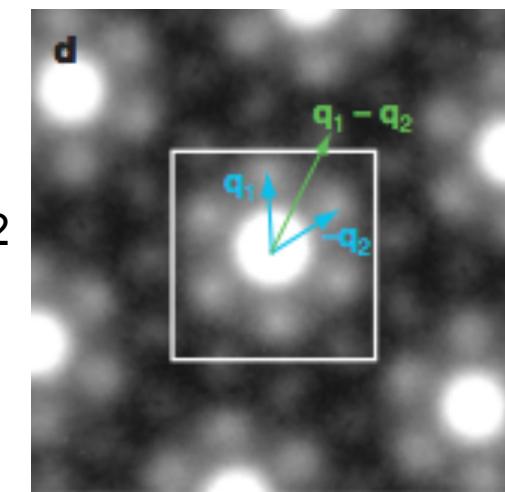
experimental techniques for microscopic understanding

Electronic structure dynamics
→ photoemission



Bi

Lattice dynamics
→ diffraction



TaS₂

Electron sources for ultrafast diffraction

Compact and efficient - 10^5 gain in elastic scatt. cross section

Photocathode + static field: < 100 keV & < fC charge & > 300 fs

Space charge limit

Sciaiani and Miller, Rep. Prog. Phys. **74**, 096101(2011)

Velocity dispersion

Photocathode + RF field: sub-100 fs & pC charge

RF compression of 100 keV electrons - Van Oudheusden *et al.*, PRL **105**, 264801 (2010)

RF MeV guns - Musumeci *et al.*, Appl. Phys. Lett. **97**, 063502 (2010)

Synchronization and jitter: resolution > 100 fs

REQUIREMENTS

- time resolution < 10 fs*
- energy 50 keV – 5 MeV
- energy spread < few %
- charge fC – pC
- emittance < 0.1 mm.mrad
- rep rate > 100 Hz
- stability < few %

*Many phonon modes with period < 100 fs, (10 fs in graphene)

Why laser wakefield accelerators ?

Pros

- Few femtosecond duration*
- 100 keV/ μm accelerating gradient
 - MeV electron bunches
 - Decreases space charge
- Accelerating structure is generated by the laser pulse
 - Perfect synchronization
 - No jitter in pump-probe experiment

Cons/ open questions

- Large energy spread: 1-10%
 - Chirped bunches, stretches in time
- Stability sufficient for UED ?
- Beam quality / coherence sufficient for UED ?
- Scaling of current system ?
 - From 100 MeV to MeV
 - From Hz to kHz
 - From J laser to mJ laser

* 1.5 fs rms, O. Lundh et al., Nat. Phys. 2011

Scaling to MeV energies

$$a_0 > (\omega_0 / \omega_p)^{2/5} \quad k_p R = 2\sqrt{a_0} \quad \tau c = 2R/3$$

		Scaling law	Demonstrated experiments	Scaling laws
LASER	$\lambda_0 = 0.8 \mu\text{m}$	1 J	0.6 J	5 mJ
	$W_0 (\mu\text{m})$	10	18	2.5
	$\tau (\text{fs})$	21	30	5.7
	Intensity (W/cm^2)	3×10^{19}	3×10^{18}	8×10^{18}
PLASMA	$n_e (\text{cm}^{-3})$	5×10^{18}	7×10^{18}	6.8×10^{19}
	$L_{\text{ACCELERATION}} (\mu\text{m})$	2000	1000	45
ELECTRON BEAM	$E_{\text{MAX}} (\text{MeV})$	500	100-300	10
	$Q_{\text{MAX}} (\text{pC})$	250	50-100	30

Electron acceleration with kHz, 5 fs, mJ laser system

Salle Noire laser:

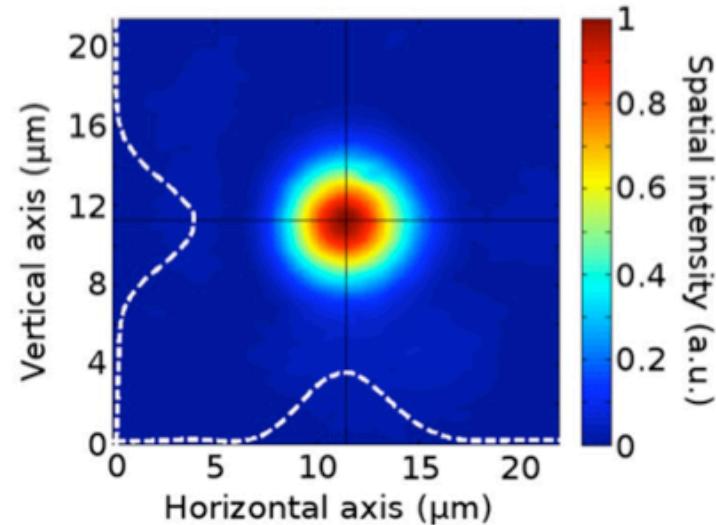
duration 4-5 fs

focused down to 1.5 μm

$I > 10^{18} \text{ W/cm}^2$

< % rms fluctuations

currently upgraded to 5 mJ



Chen et al., Laser Physics **21**, 198 (2011)

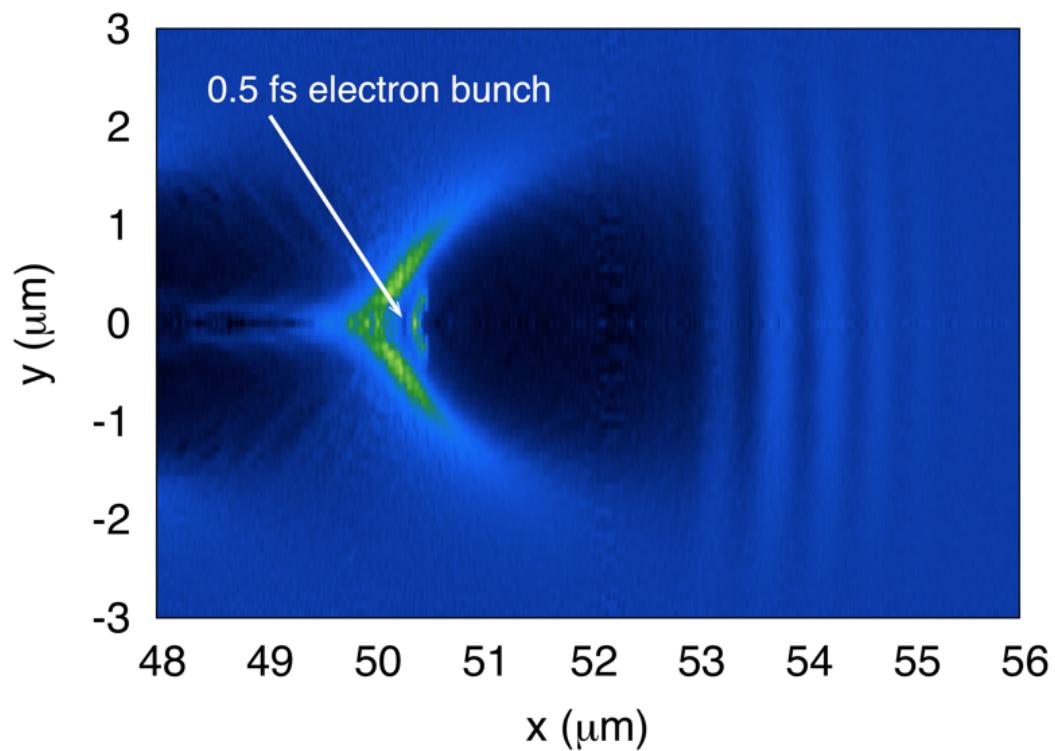
PIC simulations:

using experimental laser parameters

electronic density $n_e = 6-10 \times 10^{19} \text{ cm}^{-3}$

explore self-injection / ionization induced injection

Results of PIC simulations (Calder-Circ)



Results of PIC simulations (Calder-Circ)

Lower quality beam:

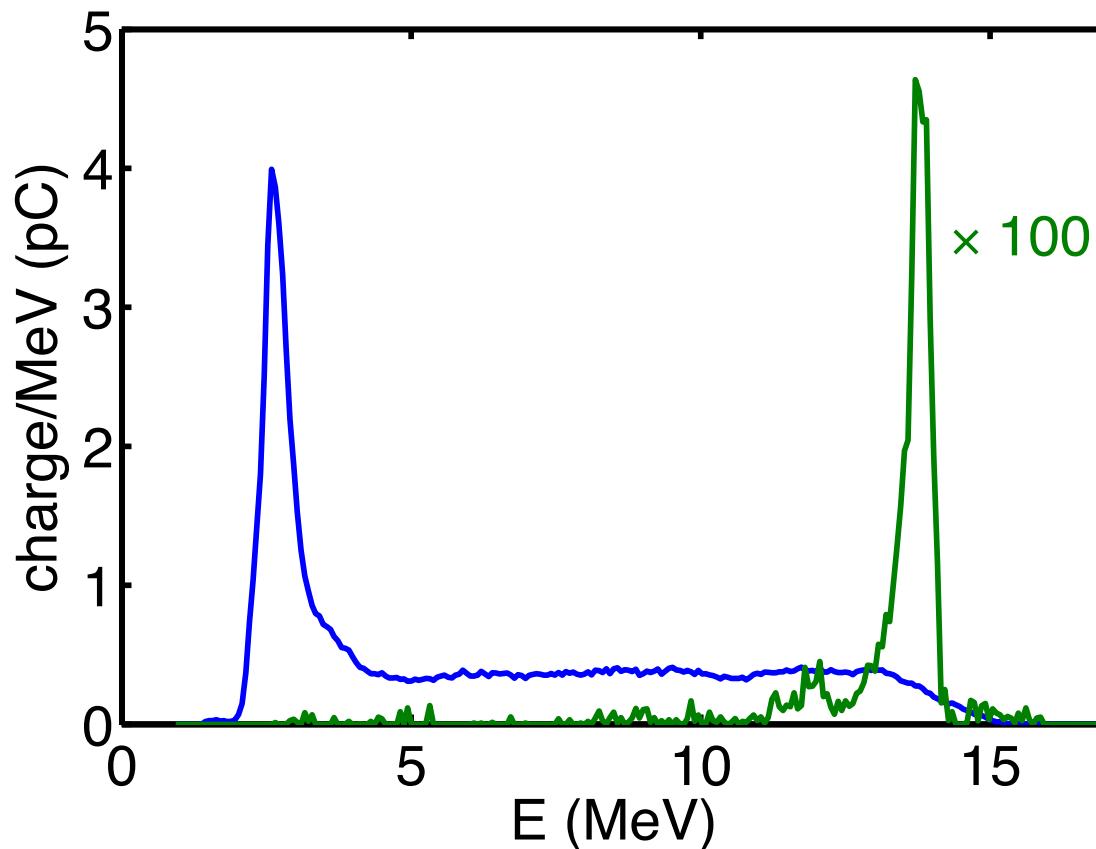
self-injection

He plasma, $n_e = 10^{20} \text{ cm}^{-3}$

fs electron bunch

larger $\delta E/E$

few pC



Higher quality beam:

ionization induced injection

N_2 plasma, $n_e = 7 \times 10^{19} \text{ cm}^{-3}$

sub-fs electron bunch

$\delta E/E = 2.5 \%$

50 fC

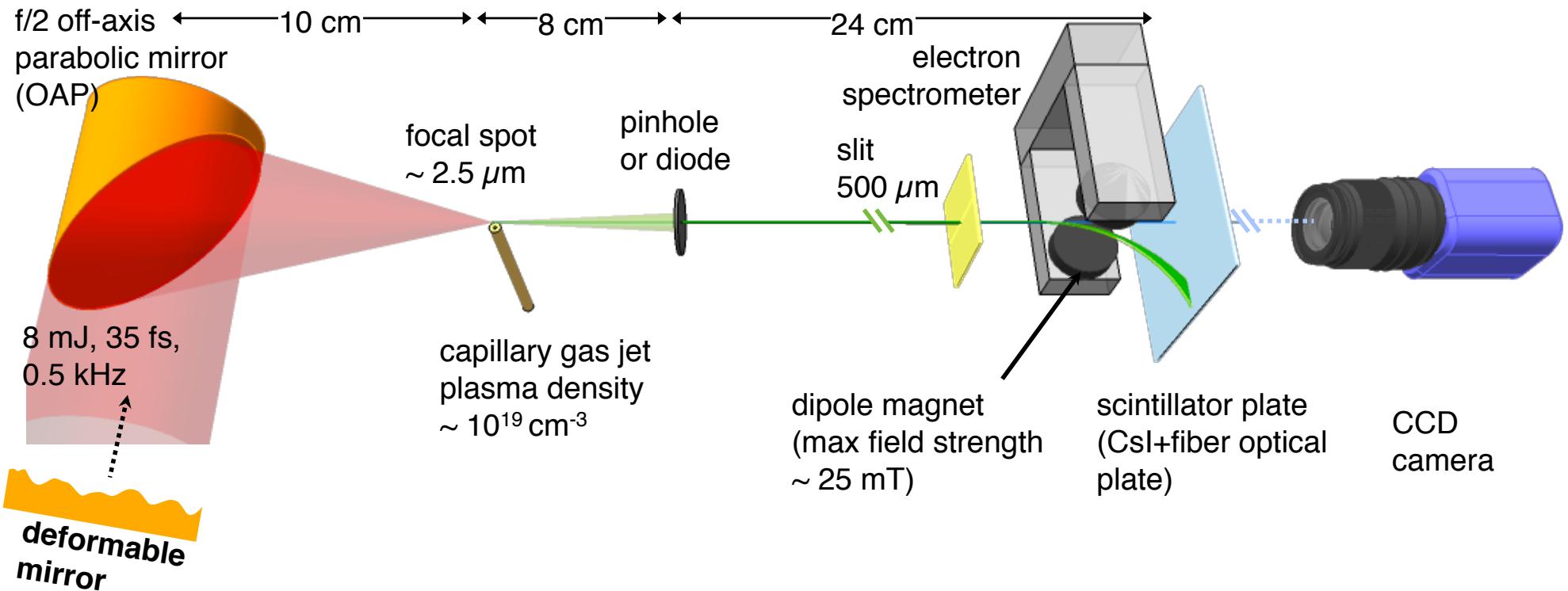
Experiments: first kHz laser-plasma accelerator



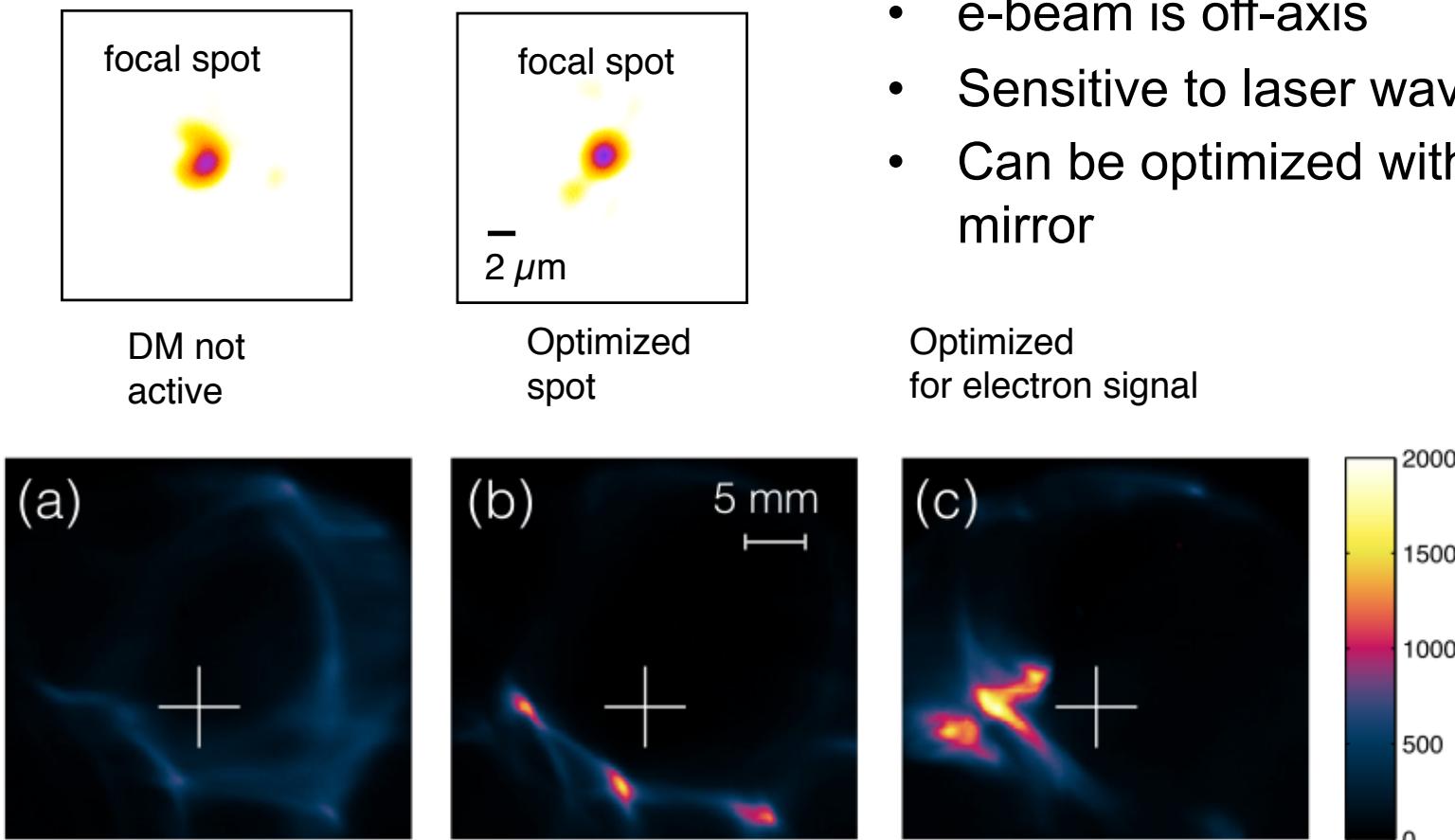
MichiganEngineering

What we need: 5 fs, 2-5 mJ, kHz, $n_e = 5-10 \times 10^{19} \text{ cm}^{-3}$

What we used: 35 fs, 8 mJ, kHz, $n_e = 10^{19} \text{ cm}^{-3}$

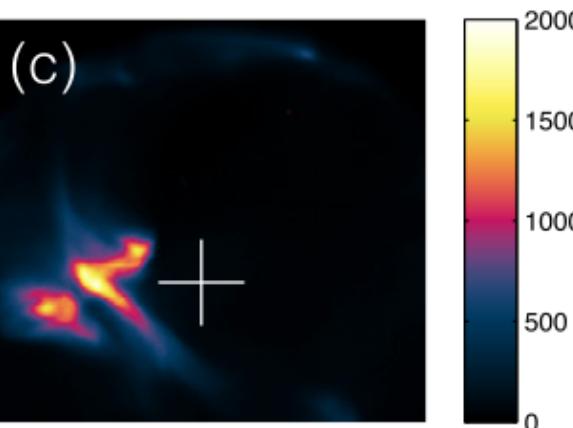


kHz beam: real time optimization



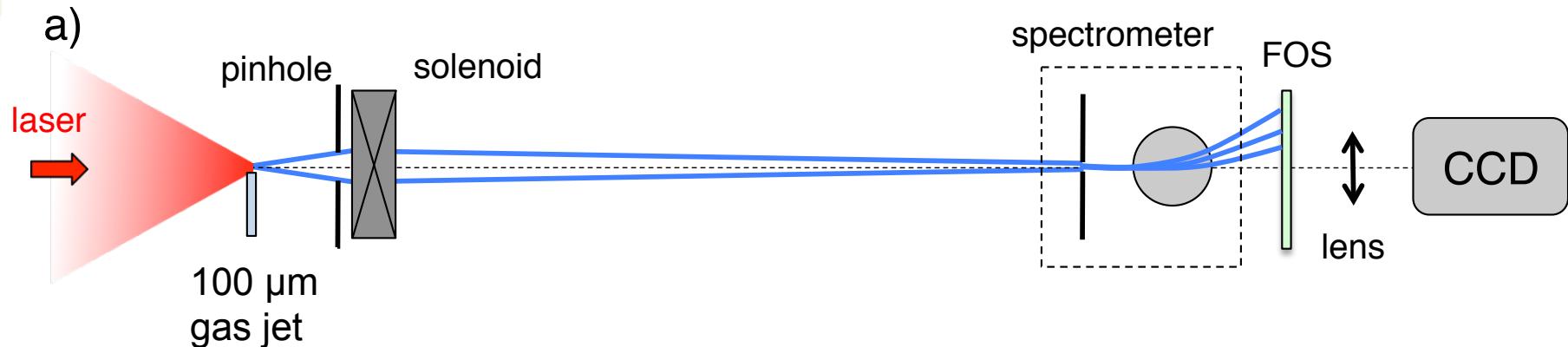
- Complex structures
- Stable ! (see later)
- e-beam is off-axis
- Sensitive to laser wavefront
- Can be optimized with deformable mirror

Optimized
for electron signal

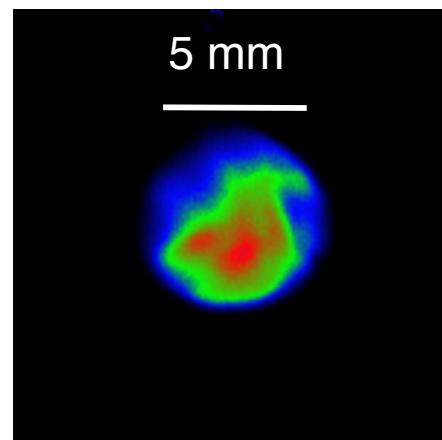


> 10 times more
electrons !

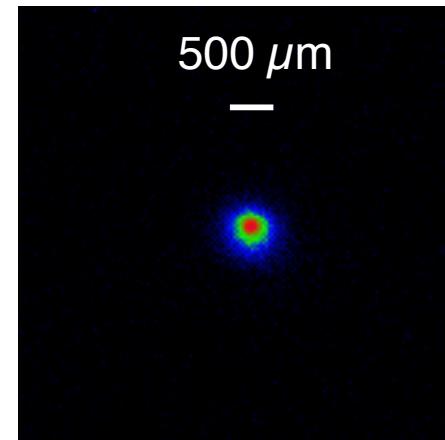
Beam manipulation with solenoid



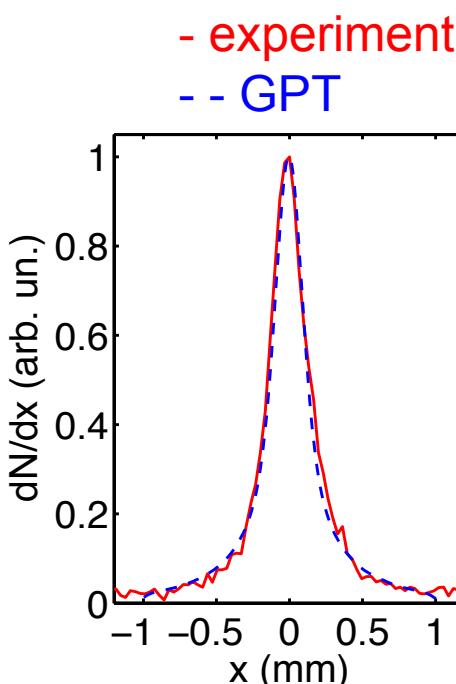
after pinhole



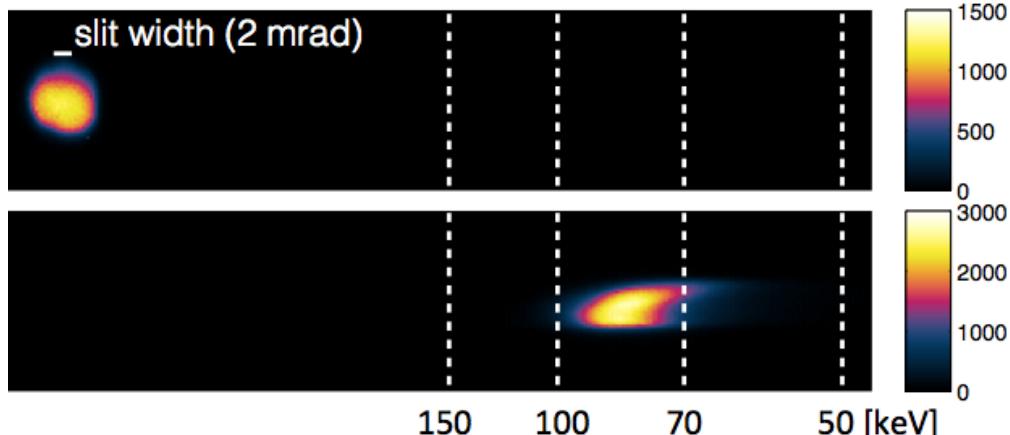
focused with
solenoid



280 μm FWHM at focus



kHz electron beam: energy distribution



Stability study

- pointing < det. lim. (400 µrad)
- energy: 100 keV fluctuations < det. lim.
- charge 3×10^4 el. (5 fC)
+/- 7% RMS

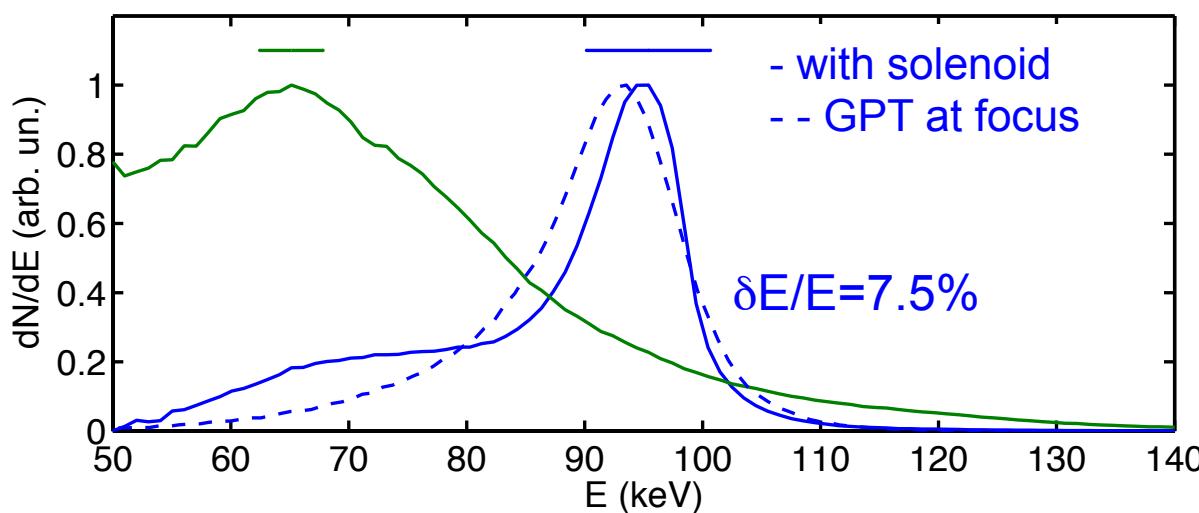
Emissance obtained from GPT
best fit to data

beam size: $\sigma_r = 15 \mu\text{m}$

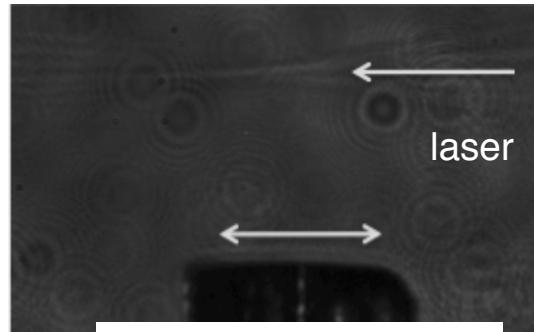
divergence: $\sigma_\theta = 5 \text{ mrad}$

$$\varepsilon_N = 2 \times 10^{-2} \text{ mm.mrad}$$

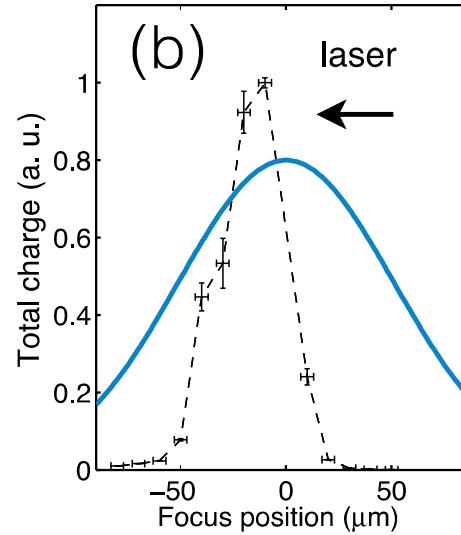
Beam transverse coherence
at focus: 5 nm



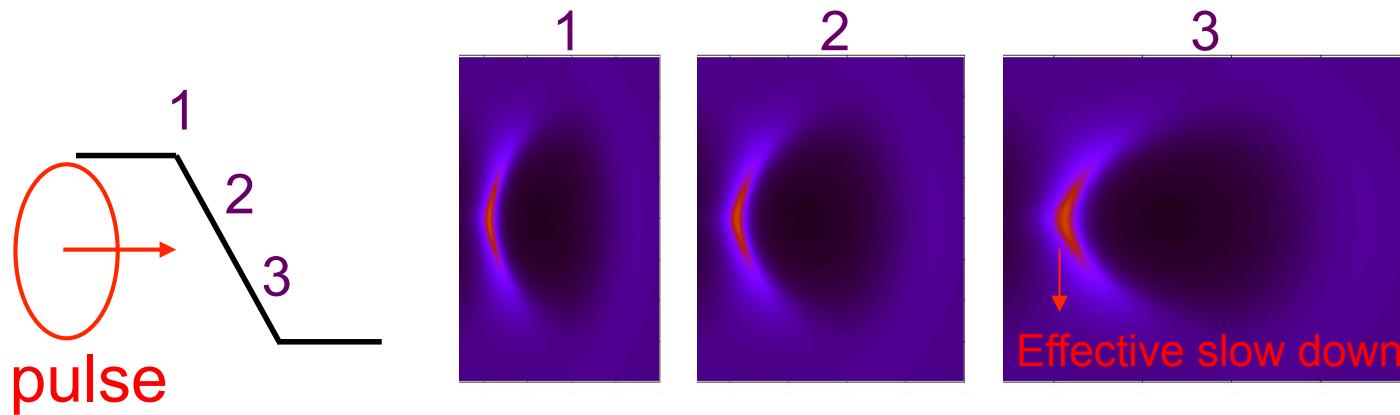
Highest charge when focusing in density down ramp



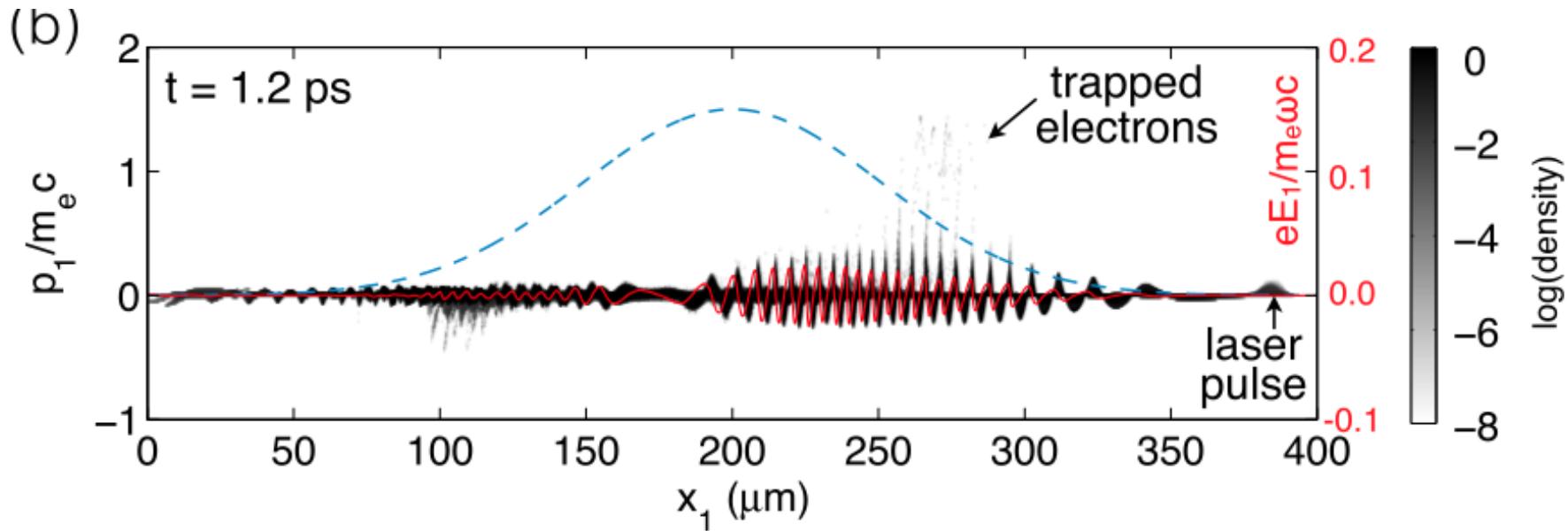
100 μm gas jet



Injection in density down ramp ?



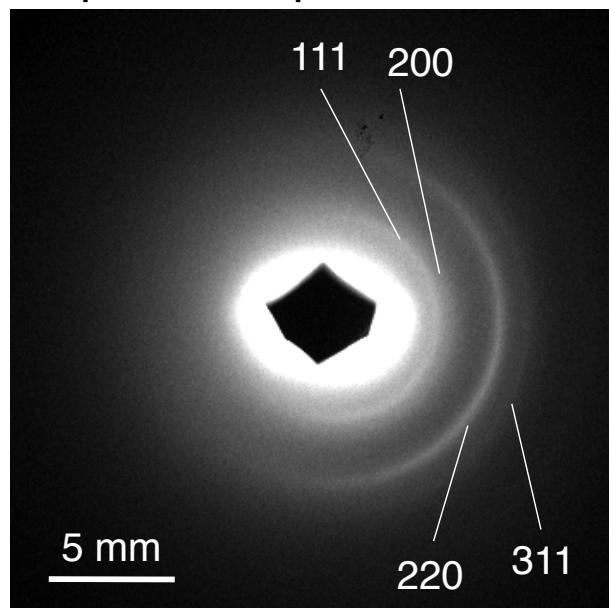
Injection in density down ramp: 2D PIC simulations



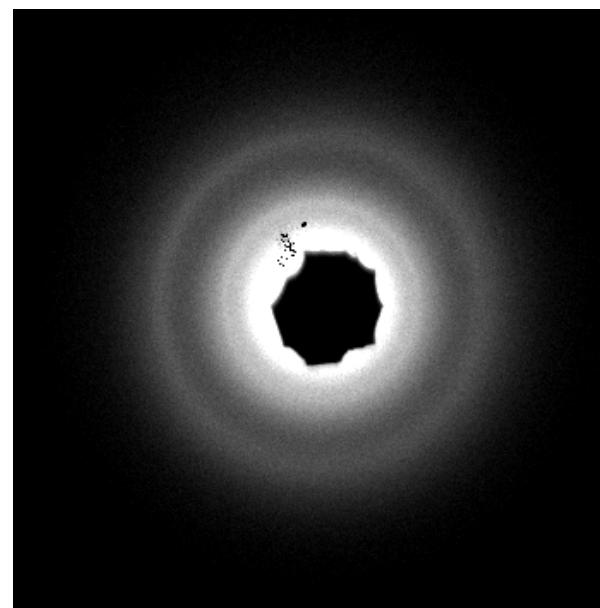
- trapping occurs $10 \lambda_p$ after laser pulse $\frac{v_{ph}}{c} = \left(1 + \frac{\zeta}{k_p} \frac{dk_p}{dx}\right)^{-1}$
- trapping in **multiple buckets*** (low charge, low beam loading)
- short accelerating length, small wake amplitude
→ small energy 100 keV

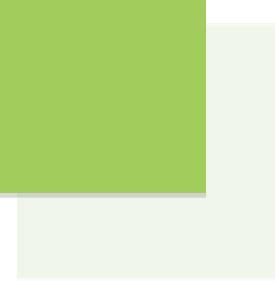
First diffraction images on 10 nm Al foil

tilted solenoid +
spatial chirp in ebeam



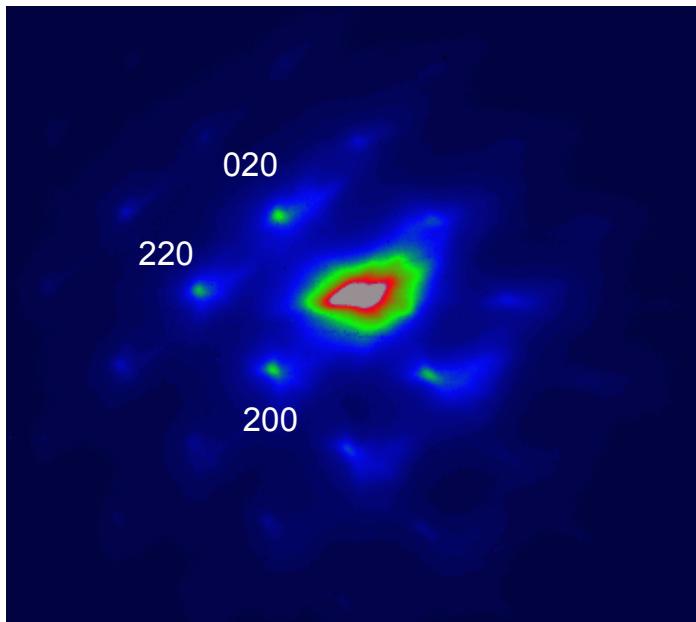
aligned solenoid
broader spectrum



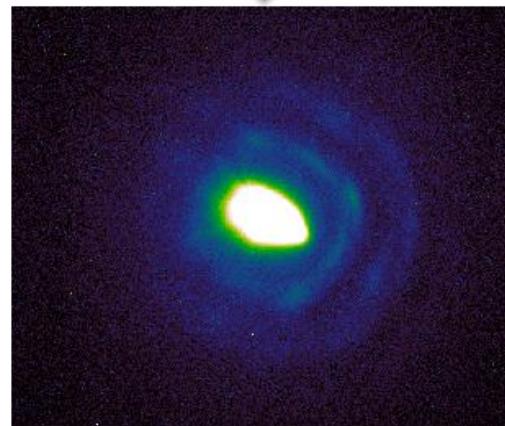
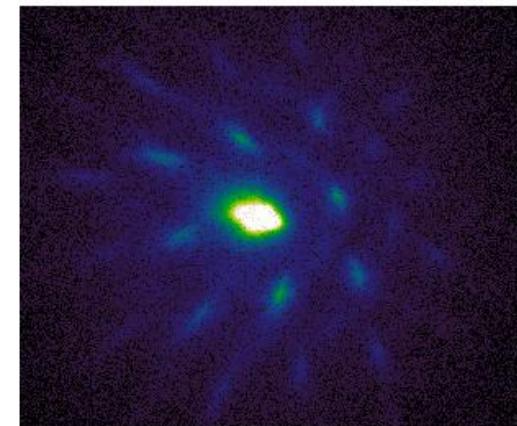


diffraction on single crystal gold

1 s integration



Laser induced
melting



- Single shot images within reach
(improve detection QE)
- Next step: time resolved study

Conclusions / perspectives

- ***First proof-of-principle experiment with mJ, kHz laser***
 - 100 keV energy level
 - not femtosecond
 - transverse coherence for diffraction patterns
 - clear / useable diffraction patterns
 - stability
- ***Perspectives: FEMTOELEC project***
 - Currently upgrading kHz laser system to 5 fs, 5 mJ
 - Currently building experiment (vacuum chambers ...)
 - perform experiments with 5 fs laser pulses: MeV e-beams
 - Single fs bunches
 - Beam transport and manipulation
 - Ultrafast electron diffraction on samples

**Opportunity to test practicality of plasma source for
A real & demanding scientific application**

Collaborators

FemtoElec



Few-cycle 5 fs laser system:

PCO group at LOA:

R. Lopez-Martens, [M. Bocoum](#), A. Jullien, J.-P. Rousseau, B. Mercier



Experiments: Electron source for UED:

APPLI group at LOA:

[B. Beaurepaire](#), [M. Thévenet](#), A. Vernier, G. Gallé, D. Boschetto

CUOS of University of Michigan:

[Z. He](#), A. Thomas, J. Nees, K. Krushelnick



Simulations / theory

A. Lifschitz (LOA, France)

Beam transport

J. Luiten's group, Univ. Eindhoven

Samples ...